AMENDMENT UNDER 37 C.F.R. § 1.111 Attorney Docket No.: Q94611

Application No.: 10/580,110

AMENDMENTS TO THE CLAIMS

This listing of claims will replace all prior versions and listings of claims in the

application:

LISTING OF CLAIMS:

1. (currently amended): A sealing material comprising a coating film comprising at

least one kind of a metal or a metallic compound selected from the group consisting of metals,

metal oxides, metal nitrides, metal carbides and complex thereof on the whole or a part of the

surface of a substrate comprising a soft material having-the a shore D hardness of at most 75 and

the a shore A hardness of 40 to 100,

wherein the soft material is a fluorine polymer material, and

wherein the soft material and the coating film are closely adhered with each other at a

degree of adhesivity where the critical breaking load is at least 25 mN, which is measured with

the microscratch test under test conditions of a curvature radius of diamond stylus of 5.0 µm; an

elastic arm of 146.64 g/mm; a stage angle of 3.0°; a measurement speed of 10.0 μm/s; a load

applying speed of 75.31 mN/mm; an excitation width of 79 µm; and an excitation frequency of

30 Hz.

2. (original): The sealing material of Claim 1, wherein the soft material is an

elastomer.

3. (canceled).

4. (previously presented): The sealing material of Claim 1, wherein the soft material

is a fluorine rubber.

2

AMENDMENT UNDER 37 C.F.R. § 1.111 Attorney Docket No.: Q94611

Application No.: 10/580,110

5. (previously presented): The sealing material of Claim 1, wherein the thickness of

the coating film is 0.005 to 1 μm .

6. (previously presented): The sealing material of Claim 1, wherein the soft material

and the coating film are closely adhered with each other at the degree of adhesivity where the

number of peeling between the soft material and the coating film is at most 50/100, which is

measured by the cross-cut tape adhesion test (1 mm square/100 pieces) according to JIS K5600.

7. (canceled).

8. (currently amended): The sealing material of Claim 1, wherein all the rates of

decrease in weight of sheet sample having a thickness of 2 mm and a size of 10 mm x 35 mm are

at most 1 % by weight at irradiating respective plasmas of O₂, CF₄, and NF₃ under O₂ plasma and

CF₄ plasma irradiation conditions of a gas flow rate of 16 SCCM; a pressure of 20 mTorr; an

output power of 800 W; and an irradiation time of 30 minutes, and under NF₃ plasma irradiation

conditions of NF₃/Ar of 1 SLM/1 SLM; a pressure of 3 Torr; an irradiation time of 2 hours; and a

temperature of 150°C the following conditions:

Note:

Samples: A sheet having a thickness of 2 mm and a size of 10 mm x 35 mm

Irradiation conditions:

O₂ plasma and CF₄ plasma Gas flow rate ••• 16 SCCM

Pressure ••• 20 mTorr

Output power *** 800 W

Irradiation time ••• 30 minutes

NF₃-plasma NF₃/Ar ••• 1-SLM/-1-SLM

Pressure ••• 3 Torr

3

AMENDMENT UNDER 37 C.F.R. § 1.111 Attorney Docket No.: Q94611

Application No.: 10/580,110

Irradiation time ••• 2 hours

Temperature ••• 150°C.

9. (previously presented): The sealing material of Claim 1, wherein the coating film

is formed by a vacuum film forming process.

10. (original): The sealing material of Claim 9, wherein the vacuum film forming

process is an ion plating process.

11. (previously presented): The sealing material of Claim 1, which is used for

equipment for manufacturing a liquid crystal or a semiconductor.

12. (previously presented): A liquid crystal or semiconductor manufacturing

equipment which has the sealing material of Claim 1.

13. (original): A process for preparing a sealing material comprising a step of coating

the whole or a part of the surface of a substrate comprising of a soft material having the shore D

hardness of at most 75 and the shore A hardness of 40 to 100 with at least one kind of a metal or

a metallic compound selected from the group consisting of metals, metal oxides, metal nitrides,

metal carbides and complexes thereof by ion plating process.

4